



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Kwang-Hook KIM et al.

Examiner: R. Culbert

Application No.: 10/022,357

Group Art Unit: 1763

Filed: December 20, 2001

Attorney Dkt. No.: 101190-00022

For: METHOD FOR MANUFACTURING CATALYTIC OXIDE ANODE USING HIGH TEMPERATURE SINTERING

AMENDMENT UNDER 37 CFR § 1.111

Director for the U.S. PTO
P.O. Box 1450
Alexandria, VA 22313-1450

Date: March 26, 2004

Sir:

In reply to the outstanding Office Action dated November 26, 2003, the time period for response having been extended from February 26, 2004 to March 26, 2004 by the enclosed Petition for Extension of Time, please amend the above-identified application as follows: